## INFORMAL COMMUNICATION PROPOSED AMENDMENT

Serial No. 09/627,559

**Examiner Bernard Souw** 

Art Unit 2881

10 DEC 2002

## IN THE SPECIFICATION

## Page 4, paragraph starting at line 13:

2033276401

The Etendu of a laser plasma source is defined as the product of the illuminated surface of an imaginary unit sphere around the source and the square of the aperture engle Numerical Aperture at which each field point of the imaginary unit source sees the spherical source.

## IN THE CLAIMS

- 48. (Amended Twice amended) The illumination system of claim 4746, wherein said optical unit comprises a structure having a plurality of sides, wherein each of said plurality of sides corresponds to one of said plurality of primary light sources, and wherein said second plurality of raster elements is arranged on said plurality of sides.
- 63. (New) The illumination system of claim 45, wherein said optical unit comprises a structure having a plurality of sides, wherein each of said plurality of sides corresponds to one of said plurality of primary light sources, and wherein said second plurality of raster elements is arranged on said plurality of sides.
- 64. (New) The illumination system of claim 45, wherein said optical unit comprises a plurality of structures,